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Attorney Docket No. 0756-7272

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hongyong ZHANG et al.

Serial No. 10/808,353

Filed: March 25, 2004

For: SEMICONDUCTOR DEVICE AND
METHOD FOR ITS PREPARATION

) Group Art Unit: 2811

) Examiner:

CERTIFICATE OF MAILING

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REQUEST FOR CORRECTED PTO 1449 FORM

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It has come to the attention of Applicant that the two of the articles listed on the PTO 1449 Form accompanying the Information Disclosure Statement filed March 25, 2004 need be revised to include further information. Specifically, Volume 60, No. 2, pages 225-227, should be added to the citation for the article entitled *In Situ Transmission Electron Microscopy Studies of Silicide-Mediated Crystallization of Amorphous Silicon*, and pages 8279-8289 should be added to the citation of the article entitled *Silicide Formation and Silicide-Mediated Crystallization of Nickel-Implanted Amorphous Silicon Thin Films*. Therefore, it is respectfully requested that the Examiner line through the erroneous listing on the PTO 1449 filed March 25, 2004, and evidence his consideration of the above-mentioned articles by initialing the attached PTO 1449 Form.

Respectfully submitted,

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